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PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Michael J. Scaggs

Application No.: 09/733,874

Filed: December 8, 2000

For: 157 NM LASER SYSTEM AND  
METHOD FOR MULTI-LAYER  
SEMICONDUCTOR FAILURE  
ANALYSIS

Confirmation No.: 3133

Group Art Unit: 2815

Examiner: J.R. Diaz

**SUBMISSION OF FORMAL DRAWINGS**

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M/S ISSUE FEE

Commissioner for Patents

Attn: Official Draftsperson

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**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited  
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STALLMAN & POLLOCK LLP

Dated: 06/3/2004

By:

Georgia K. Smith  
Georgia K. Smith

Sir:

In response to the Notice of Allowance and Issue Fee(s) Due mailed May 12, 2004,  
enclosed are two (2) sheets of formal replacement drawings for filing in the above-referenced  
application.

Respectfully submitted,

STALLMAN & POLLOCK LLP

Dated: June 2, 2004

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